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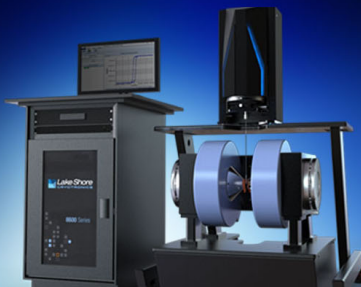
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Resonant transmission of light through surface plasmon structures

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Plasmonics enables the realization of new optical components. Here, we report yet another plasmonic component based on a pair of surfaces displaying grating coupled plasmon enhanced transmission. We observe high quality factor transmission peaks as high as 100 through our plasmonic filter based on gratings obtained directly from optical storage disks. Wavelength and polarization dependent transmission is also demonstrated in the visible and infrared portions of the spectrum. The resonance wavelength of this filter can be tuned by simply changing the angle of incidence. Numerical calculations agree well with measurements. Our work can open up directions toward disposable optical components such as filters and polarizers. © 2009 American Institute of Physics. [DOI: 10.1063/1.3151828]

In recent years, plasmonics has attracted a great deal of attention due to its important potential technological applications in sensing, imaging and information processing.^{1,2} Although plasmonic structures have been extensively studied for better understanding of fundamental physical phenomenon, optoelectronic device applications generally focused on sensors.³ Since the pioneering works of Ebbesen *et al.*⁴ and Ghaemi *et al.*⁵ transmission of electromagnetic waves through thin metal films via plasmons has widely been studied. Plasmon resonance enhanced transmission through sub-wavelength holes, hole arrays or periodically corrugated metal surfaces have been investigated both theoretically and experimentally.^{6–10} The resonant transmission peaks due to interacting plasmonic structures (weak coupling regime) have been observed in silver films containing an array of Silicon spheres.¹¹ Optical properties of the periodic arrays of defects (voids) in mesoporous metals¹² and two-dimensional metallic quasiphotonic crystals¹³ have also been investigated.

In this article, we report observation of sharp transmission resonances in coupled surface-plasmon on metallized grating structures which are obtained from optical storage disks. A filter based on plasmon enhanced transmission (PET) in metal coated coupled-grating structures is proposed and experimentally demonstrated. The filter consists of two metallized gratings placed back to back, as shown in Fig. 1(a). In an optimized layer structure with sufficiently thin metal layer, light is partially transmitted through the metal layer and is partially diffracted or re-emitted into different orders with different angles of propagation. For our proposed structure, the transmitted orders travel inside the substrate and are incident onto an identical grating on the other face of the substrate. Due to the symmetry of the device, components of the light wave that are generated through plasmonic emission recouple to the plasmon mode and a second event of PET takes place at the second grating. The distance between the two surfaces carrying the gratings, t , is very large compared to the plasmon propagation length and free space wavelength ($t \gg \xi, \lambda$). Under this condition, the reflected waves from the second surface do not interfere with (regen-

erate) the plasmons on the first surface,¹ hence our analysis remains valid.

Figure 1(b) shows the calculated field distribution through the device for wavelength $\lambda=580$ nm and angle of incidence $\theta_i=15^\circ$ ($\Lambda=740$ nm and $\Lambda \ll t$). It can be seen that the electromagnetic (EM) waves are re-emitted from second grating layer at the same angle of incidence as the incoming wave. Even though the dielectric layer thickness between the gratings is on the order of 1 mm in real device structures, it is assumed to be 10 μm to avoid computational difficulties in the finite difference time domain (FDTD) simulations. In this case, t is much larger than the wavelength of light of incident beam, but it is comparable to the plasmon propagation length.

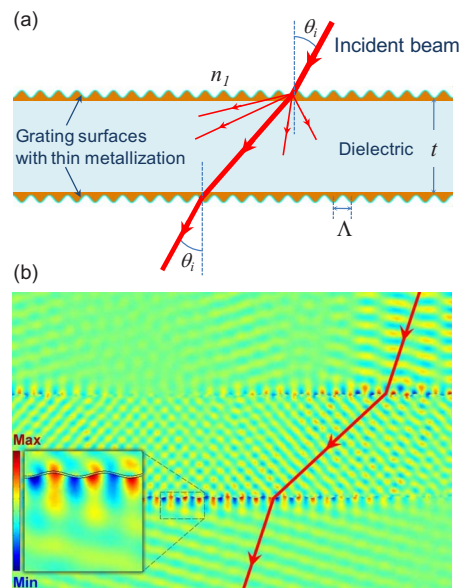


FIG. 1. (Color online) (a) Surface plasmons on coupled nanostructured gratings. The plasmonic filter consists of two metallized grating surfaces placed in a symmetrical fashion with a dielectric layer in between. Due to PET, light is radiated within the substrate into different diffraction orders. At the back side, as the same matching condition holds, light again couples to the plasmon mode and is radiated to vacuum at the same angle as the angle of incidence to the first surface. (b) Calculated H_z component of EM wave through coupled plasmonic structure agrees well with proposed scheme. Inset shows the plasmonic radiation from sinusoidal grating.

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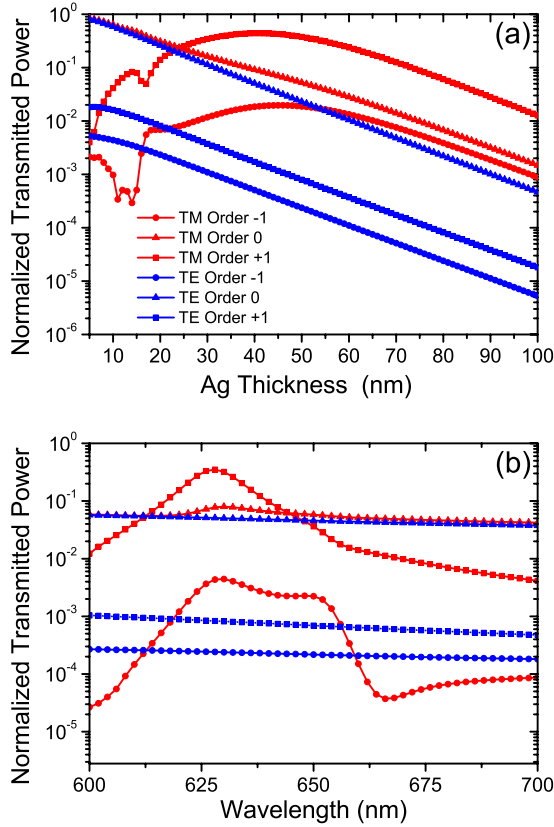


FIG. 2. (Color online) (a) Transmitted fraction of light on resonance as a function of metal thickness for $\theta_i=10^\circ$ and $\lambda=630$ nm. Since TE mode is not resonantly transmitted, the filter also acts as a polarizer, transmitting mainly TM polarization. Optimal Ag thickness is seen to be about 45 nm. (b) Transmitted fraction of light as a function of wavelength for the -1^{st} , 0^{th} , and $+1^{\text{st}}$ diffraction orders, for incidence angle $\theta_i=10^\circ$ and $t_{\text{Ag}}=45$ nm.

When a collimated beam of light is incident upon a metal grating, resonant coupling to the surface plasmon mode occurs at angles given by¹⁴

$$\Theta_{\text{SP}} = \arcsin \left[\text{Re} \left(-\sqrt{\frac{n_1^2 n_2^2}{n_1^2 + n_2^2}} \right) + m \frac{\lambda}{n_1 \Lambda} \right], \quad (1)$$

where Λ is the grating period, n_1 is the complex index of refraction of the dielectric medium, n_2 is that of the metal layer and m is an integer. Resonant coupling occurs for only transverse magnetic (TM) polarization (the TM radiation is incident in a plane parallel to the grating wave vector), where the grating vector is parallel to the plane of incidence.¹⁵ On the other hand, depth and shape of the grating also affects the width of the resonance.¹⁶

We calculated the transmission intensity through single layer of silver-coated grating with $\Lambda=740$ nm as a function of metal thickness [Fig. 2(a)] and wavelength [Fig. 2(b)] of incoming wave by using rigorously coupled wave analysis (RCWA).¹⁷ As shown in Fig. 2(a), the transmitted power for $+1^{\text{st}}$ diffraction order reaches its maximum value near 45 nm silver thickness for TM waves. On the other hand, the transmitted intensity for all the other diffracted orders for transverse electric (TE) and TM waves is an order of magnitude smaller. Figure 2(b) shows wavelength dependence of transmitted power for different diffraction orders of both TE and TM modes. The maximum value of the $+1^{\text{st}}$ diffraction order for TM mode for incidence angle $\theta_i=10^\circ$ occurs at wavelength $\lambda=628$ nm. The filter acts also as a polarizer, with a TM/TE polarization ratio of about 100.

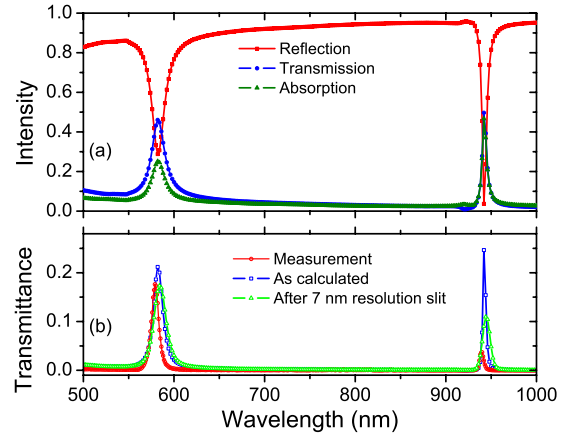


FIG. 3. (Color online) (a) Calculated reflection, transmission and absorption spectra as a function of wavelength for TM waves. Calculation parameters are grating period $\Lambda=740$ nm, silver thickness $t_{\text{Ag}}=45$ nm and incidence angle $\theta_i=15^\circ$. (b) Comparison of measured and calculated transmittance as a function of wavelength. Finite resolution of the spectrometer partially explains the discrepancy between calculations and measurement around 950 nm.

In order to implement the structure, we use gratings present on optical storage disks. Previously, compact disks (CDs) and digital versatile disks (DVDs) have been used in experiments involving grating coupled plasmons.^{18,19} However, to observe sharp resonances, the depth and shape of corrugations must lie within a restricted range. Most commercially available optical disks have corrugated imprinted surfaces protected by external coatings. By exposing the surfaces, simple chemical procedures can be used to tune the surface profile to optimal geometries for sharp and deep plasmon resonance peaks.¹⁶

We exposed the grating surface of a DVD, by mechanically separating the protective layer. The dye layer can be rinsed using isopropanol or dilute nitric acid, without damaging the grating structure. The grating depth can be adjusted to around 35 nm by chemically etching the polycarbonate disk in a 1:4 acetone/isopropanol solution for about 45 s. Atomic force microscope (PSIA XE100) was used to characterize the resulting topographies, showing nearly sinusoidal gratings with depths of 35 nm. Two such surfaces are fixed back to back using a thin UV curable epoxy layer. Then the surfaces are metallized by vacuum evaporation of a 45 nm thick silver layer. A similar procedure was repeated using a CD, where the grating depth was tuned to 60 nm. The transmission through the structures were measured using spectrometric ellipsometers (J. A. Woollam VASE) in the visible and in the near infrared.

The total transmission through the coupled plasmonic grating structure as a function of wavelength for 15° angle of incidence is calculated by using RCWA and is shown in Fig. 3(a), where $\Lambda=740$ nm. The measured transmittance through the filter for $\theta_i=15^\circ$ shows peak at wavelengths $\lambda=580$ and 940 nm. As shown in Fig. 3(b), the simulations explain the measured spectra quantitatively if a finite spectrometer resolution is assumed.

We measured the transmittance through the proposed plasmonic filter for various incidence angles ranging from $\theta_i=0^\circ$ to 20° (Fig. 4). It can be seen that, a peak transmission of up to 0.17 can be achieved over a broad wavelength range, with full width at half maximum of 10 to 5 nm. The positions

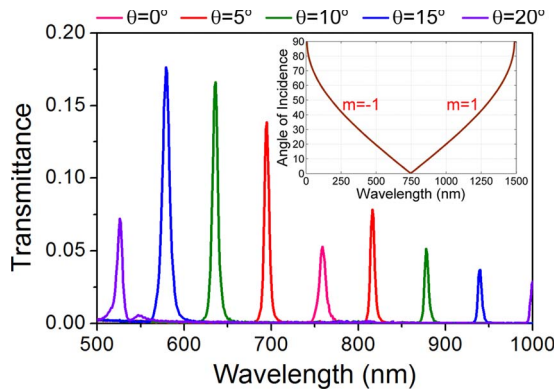


FIG. 4. (Color online) Transmitted intensity of a device having a grating period of $\Lambda=740$ nm and $t=1$ mm at various angles of incidence, as measured with a spectroscopic ellipsometer. No significant transmission for TE waves is observed. The quality factors of transmission peaks are about 100. The inset shows the theoretical results obtained from Eq. (1).

of the peaks agree well with the predictions of RCWA simulations. For instance, the results shown at Fig. 2 predicts the transmission peak to occur at $\lambda=628$ nm for 45 nm thick Ag coated grating and 10° of incidence angle, at the experiment we obtain the transmission peak at $\lambda=635$ nm for the same structure. As shown in the inset in Fig. 2, Eq. (1) predicts the positions of transmission peaks, which agree well with measured results, for a given incidence angle. Two peaks symmetric about $\lambda=750$ nm corresponding to $m=1$ and $m=-1$ are observed (n and k values are taken from Ref. 20).

For the device fabricated using CDs with grating periods of $\Lambda=1600$ nm, PET phenomena can be observed in the near infrared portion of the spectrum at angles of incidence close to normal, as shown in Fig. 5. Due to finite transmission of the CD material (characterized by Fourier transform infrared spectrometer, data not shown), and relatively large thickness of the double CD substrate (3 mm), total transmission at the resonant wavelength is reduced to few percent. However, well defined resonances with widths of about 50 nm can be observed. This corresponds to a peak wavelength to width ratio of about 40, which compares favorably with previously reported PETs at similar wavelengths.^{21,22}

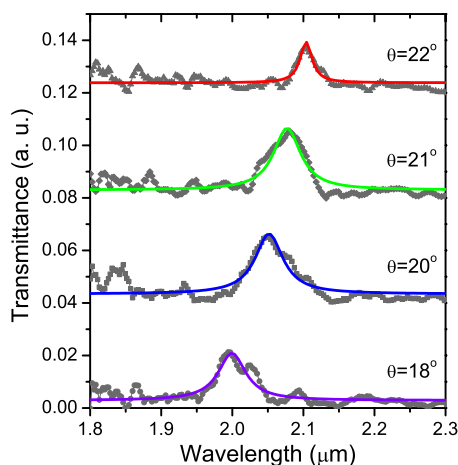


FIG. 5. (Color online) Measured transmitted intensity of a device having a grating period of $\Lambda=1600$ nm at various angles of incidence.

In summary, we proposed and demonstrated an optical filter that uses PET through metallized gratings. The devices are realized using optical disks as starting substrates. Sharp transmission peaks with peak wavelengths dependent on the angle of incidence make the devices suitable for applications in compact spectrometers. By fabricating the device using an elastomeric substrate, peak wavelength can be tuned by applying strain.^{23,24} Theoretical calculations and measurements predict that such devices can be operated at infrared wavelengths by proper scaling. When used to filter collimated thermal emission, devices can be used to fabricate tunable, polarized infrared light sources, or disposable infrared spectrometers. It would be interesting to investigate an array of coupled plasmonic structures by varying the distance between plasmonic gratings.^{11,12,25}

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- ¹S. A. Maier and H. A. Atwater, *J. Appl. Phys.* **98**, 011101 (2005).
- ²E. Cubukcu, N. Yu, E. J. Smythe, L. Diehl, K. B. Crozier, and F. Capasso, *IEEE J. Sel. Top. Quantum Electron.* **14**, 1448 (2008).
- ³J. Homola, *Anal. Bioanal. Chem.* **377**, 528 (2003).
- ⁴T. W. Ebbesen, H. J. Lezec, H. F. Ghaemi, T. Thio, and P. A. Wolff, *Nature (London)* **391**, 667 (1998).
- ⁵H. F. Ghaemi, T. Thio, D. E. Grupp, T. W. Ebbesen, and H. J. Lezec, *Phys. Rev. B* **58**, 6779 (1998).
- ⁶A. Giannattasio, I. R. Hooper, and W. L. Barnes, *Opt. Express* **12**, 5881 (2004).
- ⁷I. Avrutsky, Y. Zhao, and V. Kochergin, *Opt. Lett.* **25**, 595 (2000).
- ⁸N. Bonod, S. Enoch, L. Li, E. Popov, and M. Nevière, *Opt. Express* **11**, 482 (2003).
- ⁹Y.-H. Ye and J.-Y. Zhang, *Opt. Lett.* **30**, 1521 (2005).
- ¹⁰H. E. Went, A. P. Hibbins, J. R. Sambles, C. R. Lawrence, and A. P. Crick, *Appl. Phys. Lett.* **77**, 2789 (2000).
- ¹¹F. J. Garcia de Abajo, G. Gómez-Santos, L. A. Blanco, A. G. Borisov, and S. V. Shabanov, *Phys. Rev. Lett.* **95**, 067403 (2005).
- ¹²N. Stefanou, A. Modinos, and V. Yannopoulos, *Solid State Commun.* **118**, 69 (2001).
- ¹³M. Bayindir, E. Cubukcu, I. Bulu, and E. Ozbay, *Europhys. Lett.* **56**, 41 (2001).
- ¹⁴M. Kahl and E. Voges, *Phys. Rev. B* **61**, 14078 (2000).
- ¹⁵H. Raether, *Surface Plasmons on Smooth and Rough Surfaces and on Gratings* (Springer, Berlin, 1988).
- ¹⁶B. Kaplan, H. Guner, O. Senlik, K. Gurel, M. Bayindir, and A. Dana (unpublished).
- ¹⁷International Intellectual Group, Inc., PCGrate. <http://www.pcgrate.com>.
- ¹⁸B. K. Singh and A. C. Hillier, *Anal. Chem.* **78**, 2009 (2006).
- ¹⁹E. Fontana, *Appl. Opt.* **43**, 79 (2004).
- ²⁰E. D. Palik, *Handbook of Optical Constants of Solids* (Academic, New York, 1985), pp. 350–357.
- ²¹K. Ikeda, H. T. Miyazaki, T. Kasaya, K. Yamamoto, Y. Inoue, K. Fujimura, T. Kanakugi, M. Okada, K. Hatade, and S. Kitagawa, *Appl. Phys. Lett.* **92**, 021117 (2008).
- ²²H. T. Miyazaki, K. Ikeda, T. Kasaya, K. Yamamoto, Y. Inoue, K. Fujimura, T. Kanakugi, M. Okada, K. Hatade, and S. Kitagawa, *Appl. Phys. Lett.* **92**, 141114 (2008).
- ²³A. Kocabas, F. Ay, A. Dâna, and A. Aydinli, *J. Opt. A, Pure Appl. Opt.* **8**, 85 (2006).
- ²⁴A. Kocabas, A. Dana, and A. Aydinli, *Appl. Phys. Lett.* **89**, 041123 (2006).
- ²⁵M. Bayindir, B. Temelkuran, and E. Ozbay, *Phys. Rev. Lett.* **84**, 2140 (2000).